

**Search Notes**

Application No.

09/896,786

Examiner

Allan Olsen

Applicant(s)

HWANG ET AL.

Art Unit

1763

**SEARCHED**

Class	Subclass	Date	Examiner
216	13, 37, 75		
156	345.37		
427	123, 232		
438	759	5/4/2004	AWO

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
reviewd literature collected during prosecution of parent applications.  see EAST history,	5/4/2004	AWO

L Number	Hits	Search Text	DB	Time stamp
-	6563	(etch\$3 deposit\$4) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$ temperature near (window wall surface dielectric))	USPAT; EPO; JPO; DERWENT; IBM_TDB	2001/04/09 02:21
-	2454	((etch\$3 deposit\$4) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$ temperature near (window wall surface dielectric))) and (etch\$3 deposit\$4) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric))	USPAT; EPO; JPO; DERWENT; IBM_TDB	2004/05/03 18:00
-	20	((etch\$3 deposit\$4) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$ temperature near (window wall surface dielectric))) and (etch\$3 deposit\$4) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric))) and ((hinder block impede stop interfere) near (RF microwave inducti\$4))	USPAT; EPO; JPO; DERWENT; IBM_TDB	2001/04/09 02:27
-	46	((etch\$3 deposit\$4) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$ temperature near (window wall surface dielectric))) and (etch\$3 deposit\$4) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric))) and ((prevent\$3 diminish\$3 decreas\$3) near (RF microwave inducti\$4))	USPAT; EPO; JPO; DERWENT; IBM_TDB	2001/04/09 03:22
-	60	((etch\$3 deposit\$4) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$ temperature near (window wall surface dielectric))) and (etch\$3 deposit\$4) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric))) and ((hinder block impede stop interfere) near (RF microwave inducti\$4))) (((etch\$3 deposit\$4) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$ temperature near (window wall surface dielectric))) and (etch\$3 deposit\$4) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric))) and ((prevent\$3 diminish\$3 decreas\$3) near (RF microwave inducti\$4)))	USPAT; EPO; JPO; DERWENT; IBM_TDB	2003/05/27 03:56
-	0	"09/124,291"	US-PGPUB	2002/03/18 14:40
-	1	"09124291"	US-PGPUB	2002/03/18 14:41
-	0	"09124291" and pressure near bear\$3	US-PGPUB	2002/03/18 14:44
-	1	"09124291" and pressure	US-PGPUB	2002/03/18 14:46
-	0	"09124291" and bear\$3	US-PGPUB	2002/03/18 14:46
-	9	(US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$).did.	USPAT	2003/05/27 03:37
-	76	((etch\$3 deposit\$4) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$4 temperature near (window wall surface dielectric))) and (etch\$3 deposit\$4) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric))) and ((hinder block impede stop interfere) near (RF microwave inducti\$4))) (((etch\$3 deposit\$4) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$4 temperature near (window wall surface dielectric))) and (etch\$3 deposit\$4) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric))) and ((prevent\$3 diminish\$3 decreas\$3) near (RF microwave inducti\$4)))	USPAT; EPO; JPO; DERWENT; IBM_TDB	2003/05/27 03:54

-	60	(US-5772832-\$ or US-5716870-\$ or US-5707487-\$ or US-5254821-\$ or US-5192849-\$ or US-5185506-\$ or US-5147968-\$ or US-5137991-\$ or US-5132282-\$ or US-5130294-\$ or US-5125358-\$ or US-5114770-\$ or US-3638061-\$ or US-5879973-\$ or US-5866213-\$ or US-5665640-\$ or US-5653812-\$ or US-5639341-\$ or US-5567243-\$ or US-5563182-\$ or US-5538699-\$ or US-5527391-\$ or US-5514217-\$ or US-4609428-\$ or US-4842708-\$ or US-4883686-\$).did. or (US-4937094-\$ or US-4985114-\$ or US-5023056-\$ or US-5061838-\$ or US-5079334-\$ or US-5487875-\$ or US-5482611-\$ or US-5470768-\$ or US-5463014-\$ or US-5439533-\$ or US-5368685-\$ or US-5296036-\$ or US-5294694-\$ or US-5256846-\$ or US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6090303-\$ or US-6117279-\$ or US-6136685-\$ or US-6124834-\$ or US-5983906-\$ or US-5968379-\$ or US-6200911-\$ or US-6207901-\$ or US-6197166-\$).did. or (US-6190513-\$ or US-6189482-\$ or US-6178920-\$ or US-6173673-\$ or US-6158384-\$ or US-6139923-\$ or US-5994678-\$).did.	USPAT	2003/05/27 03:56
-	16	(((((etch\$3 deposit\$4) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$4 temperature near (window wall surface dielectric))) and (etch\$3 deposit\$4) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric))) and ((hinder block impede stop interfere) near (RF microwave inducti\$4))) (((etch\$3 deposit\$4) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$4 temperature near (window wall surface dielectric))) and (etch\$3 deposit\$4) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric))) and ((prevent\$3 diminish\$3 decreas\$3) near (RF microwave inducti\$4)))) not ((US-5772832-\$ or US-5716870-\$ or US-5707487-\$ or US-5254821-\$ or US-5192849-\$ or US-5185506-\$ or US-5147968-\$ or US-5137991-\$ or US-5132282-\$ or US-5130294-\$ or US-5125358-\$ or US-5114770-\$ or US-3638061-\$ or US-5879973-\$ or US-5866213-\$ or US-5665640-\$ or US-5653812-\$ or US-5639341-\$ or US-5567243-\$ or US-5563182-\$ or US-5538699-\$ or US-5527391-\$ or US-5514217-\$ or US-4609428-\$ or US-4842708-\$ or US-4883686-\$).did. or (US-4937094-\$ or US-4985114-\$ or US-5023056-\$ or US-5061838-\$ or US-5079334-\$ or US-5487875-\$ or US-5482611-\$ or US-5470768-\$ or US-5463014-\$ or US-5439533-\$ or US-5368685-\$ or US-5296036-\$ or US-5294694-\$ or US-5256846-\$ or US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6090303-\$ or US-6117279-\$ or US-6136685-\$ or US-6124834-\$ or US-5983906-\$ or US-5968379-\$ or US-6200911-\$ or US-6207901-\$ or US-6197166-\$).did. or (US-6190513-\$ or US-6189482-\$ or US-6178920-\$ or US-6173673-\$ or US-6158384-\$ or US-6139923-\$ or US-5994678-\$).did.)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/27 03:57

-	9	((US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$).did.) and (((etch\$3 deposit\$4) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$4 temperature near (window wall surface dielectric))) and (etch\$3 deposit\$4) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric))) and ((hinder block impede stop interfere) near (RF microwave inducti\$4))) (((etch\$3 deposit\$4) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$4 temperature near (window wall surface dielectric))) and (etch\$3 deposit\$4) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric))) and ((prevent\$3 diminish\$3 decreas\$3) near (RF microwave inducti\$4)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/29 02:04
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-	25	<p> ((((((etch\$3 deposit\$4) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$4 temperature near (window wall surface dielectric))) and (etch\$3 deposit\$4) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric))) and ((hinder block impede stop interfere) near (RF microwave inducti\$4))) (((etch\$3 deposit\$4) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$4 temperature near (window wall surface dielectric))) and (etch\$3 deposit\$4) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric))) and ((prevent\$3 diminish\$3 decreas\$3) near (RF microwave inducti\$4)))) not ((US-5772832-\$ or US-5716870-\$ or US-5707487-\$ or US-5254821-\$ or US-5192849-\$ or US-5185506-\$ or US-5147968-\$ or US-5137991-\$ or US-5132282-\$ or US-5130294-\$ or US-5125358-\$ or US-5114770-\$ or US-3638061-\$ or US-5879973-\$ or US-5866213-\$ or US-5665640-\$ or US-5653812-\$ or US-5639341-\$ or US-5567243-\$ or US-5563182-\$ or US-5538699-\$ or US-5527391-\$ or US-5514217-\$ or US-4609428-\$ or US-4842708-\$ or US-4883686-\$).did. or (US-4937094-\$ or US-4985114-\$ or US-5023056-\$ or US-5061838-\$ or US-5079334-\$ or US-5487875-\$ or US-5482611-\$ or US-5470768-\$ or US-5463014-\$ or US-5439533-\$ or US-5368685-\$ or US-5296036-\$ or US-5294694-\$ or US-5256846-\$ or US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6090303-\$ or US-6117279-\$ or US-6136685-\$ or US-6124834-\$ or US-5983906-\$ or US-5968379-\$ or US-6200911-\$ or US-6207901-\$ or US-6197166-\$).did. or (US-6190513-\$ or US-6189482-\$ or US-6178920-\$ or US-6173673-\$ or US-6158384-\$ or US-6139923-\$ or US-5994678-\$).did.)) (((US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$).did.) and (((((etch\$3 deposit\$4) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$4 temperature near (window wall surface dielectric))) and (etch\$3 deposit\$4) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric))) and ((hinder block impede stop interfere) near (RF microwave inducti\$4))) (((etch\$3 deposit\$4) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$4 temperature near (window wall surface dielectric))) and (etch\$3 deposit\$4) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric))) and ((prevent\$3 diminish\$3 decreas\$3) near (RF microwave inducti\$4)))))) </p>	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/29 01:59
-	6	<p> (US-6280563-\$ or US-6231776-\$ or US-6189482-\$ or US-6136685-\$ or US-6051286-\$ or US-6036878-\$).did. </p>	USPAT	2003/05/29 01:58

-	4	((US-6280563-\$ or US-6231776-\$ or US-6189482-\$ or US-6136685-\$ or US-6051286-\$ or US-6036878-\$).did.) and ((US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$).did.) and (((etch\$3 deposit\$4) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$4 temperature near (window wall surface dielectric))) and (etch\$3 deposit\$4) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric))) and ((hinder block impede stop interfere) near (RF microwave inducti\$4))) (((etch\$3 deposit\$4) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$4 temperature near (window wall surface dielectric))) and (etch\$3 deposit\$4) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric))) and ((prevent\$3 diminish\$3 decreas\$3) near (RF microwave inducti\$4))))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/29 02:08
-	6	((US-6280563-\$ or US-6231776-\$ or US-6189482-\$ or US-6136685-\$ or US-6051286-\$ or US-6036878-\$).did.) and ((etch\$3 deposit\$4) near (metal\$3 pt cu al ti ru ir conduct\$3) (RF microwave inducti\$4 heat\$4 temperature) near (window wall surface dielectric) (hinder block impede stop interfere) near (RF microwave inducti\$4) (prevent\$3 diminish\$3 decreas\$3) near (RF microwave inducti\$4)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/29 04:30
-	4	((("6280563") or ("6136685")).PN.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/29 04:32
-	1	((("6280563") or ("6136685")).PN.) and (Pt platinum)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/29 04:50
-	2	((((US-6280563-\$ or US-6231776-\$ or US-6189482-\$ or US-6136685-\$ or US-6051286-\$ or US-6036878-\$).did.) and ((etch\$3 deposit\$4) near (metal\$3 pt cu al ti ru ir conduct\$3) (RF microwave inducti\$4 heat\$4 temperature) near (window wall surface dielectric) (hinder block impede stop interfere) near (RF microwave inducti\$4) (prevent\$3 diminish\$3 decreas\$3) near (RF microwave inducti\$4))) and (Pt platinum)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/29 04:50
-	2	((("6280563") or ("6136685")).PN.) and heat\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/29 04:50
-	11	(US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$ or US-6280563-\$ or US-6231776-\$).did.	USPAT	2004/05/03 17:50
-	4	((US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$ or US-6280563-\$ or US-6231776-\$).did.) and (Pt platinum)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/03 17:57

-	60	(US-5079334-\$ or US-5114770-\$ or US-5125358-\$ or US-5130294-\$ or US-5132282-\$ or US-5137991-\$ or US-5147968-\$ or US-5185506-\$ or US-3638061-\$ or US-4883686-\$ or US-4842708-\$ or US-4609428-\$ or US-6117279-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6158384-\$ or US-6173673-\$ or US-6178920-\$ or US-6189482-\$ or US-6190513-\$ or US-6197166-\$ or US-6200911-\$ or US-6207901-\$ or US-5192849-\$ or US-5254821-\$).did. or (US-5256846-\$ or US-5294694-\$ or US-5296036-\$ or US-5368685-\$ or US-5439533-\$ or US-5463014-\$ or US-5470768-\$ or US-5482611-\$ or US-5487875-\$ or US-5514217-\$ or US-5527391-\$ or US-5538699-\$ or US-5563182-\$ or US-5567243-\$ or US-5639341-\$ or US-5653812-\$ or US-5665640-\$ or US-5707487-\$ or US-5716870-\$ or US-5772832-\$ or US-5866213-\$ or US-5879973-\$ or US-5968379-\$ or US-5983906-\$ or US-5994678-\$ or US-6036878-\$ or US-6051114-\$).did. or (US-6051286-\$ or US-6071372-\$ or US-6090303-\$ or US-5061838-\$ or US-5023056-\$ or US-4985114-\$ or US-4937094-\$).did.	USPAT	2004/05/03 17:57
-	15	((US-5079334-\$ or US-5114770-\$ or US-5125358-\$ or US-5130294-\$ or US-5132282-\$ or US-5137991-\$ or US-5147968-\$ or US-5185506-\$ or US-3638061-\$ or US-4883686-\$ or US-4842708-\$ or US-4609428-\$ or US-6117279-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6158384-\$ or US-6173673-\$ or US-6178920-\$ or US-6189482-\$ or US-6190513-\$ or US-6197166-\$ or US-6200911-\$ or US-6207901-\$ or US-5192849-\$ or US-5254821-\$).did. or (US-5256846-\$ or US-5294694-\$ or US-5296036-\$ or US-5368685-\$ or US-5439533-\$ or US-5463014-\$ or US-5470768-\$ or US-5482611-\$ or US-5487875-\$ or US-5514217-\$ or US-5527391-\$ or US-5538699-\$ or US-5563182-\$ or US-5567243-\$ or US-5639341-\$ or US-5653812-\$ or US-5665640-\$ or US-5707487-\$ or US-5716870-\$ or US-5772832-\$ or US-5866213-\$ or US-5879973-\$ or US-5968379-\$ or US-5983906-\$ or US-5994678-\$ or US-6036878-\$ or US-6051114-\$).did. or (US-6051286-\$ or US-6071372-\$ or US-6090303-\$ or US-5061838-\$ or US-5023056-\$ or US-4985114-\$ or US-4937094-\$).did.) and (Pt platinum) not (((US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$ or US-6280563-\$ or US-6231776-\$).did.) and (Pt platinum))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/03 18:01
-	3189	((etch\$3 deposit depositing deposition) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$3 temperature near (window wall surface dielectric))) and (etch\$3 deposit depositing deposition) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/03 18:17

-	969	<p>((etch\$3 deposit depositing deposition) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$3 temperature near (window wall surface dielectric))) and (etch\$3 deposit depositing deposition) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric)) ) and (Pt platinum) not (((US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$ or US-6280563-\$ or US-6231776-\$).did.) and (Pt platinum) (((US-5079334-\$ or US-5114770-\$ or US-5125358-\$ or US-5130294-\$ or US-5132282-\$ or US-5137991-\$ or US-5147968-\$ or US-5185506-\$ or US-3638061-\$ or US-4883686-\$ or US-4842708-\$ or US-4609428-\$ or US-6117279-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6158384-\$ or US-6173673-\$ or US-6178920-\$ or US-6189482-\$ or US-6190513-\$ or US-6197166-\$ or US-6200911-\$ or US-6207901-\$ or US-5192849-\$ or US-5254821-\$).did. or (US-5256846-\$ or US-5294694-\$ or US-5296036-\$ or US-5368685-\$ or US-5439533-\$ or US-5463014-\$ or US-5470768-\$ or US-5482611-\$ or US-5487875-\$ or US-5514217-\$ or US-5527391-\$ or US-5538699-\$ or US-5563182-\$ or US-5567243-\$ or US-5639341-\$ or US-5653812-\$ or US-5665640-\$ or US-5707487-\$ or US-5716870-\$ or US-5772832-\$ or US-5866213-\$ or US-5879973-\$ or US-5968379-\$ or US-5983906-\$ or US-5994678-\$ or US-6036878-\$ or US-6051114-\$).did. or (US-6051286-\$ or US-6071372-\$ or US-6090303-\$ or US-5061838-\$ or US-5023056-\$ or US-4985114-\$ or US-4937094-\$).did.) and (Pt platinum) not (((US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$ or US-6280563-\$ or US-6231776-\$).did.) and (Pt platinum))))</p>	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/03 18:08
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-	943	<p>(((((etch\$3 deposit depositing deposition) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$3 temperature near (window wall surface dielectric))) and (etch\$3 deposit depositing deposition) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric))) ) and (Pt platinum) not (((US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$ or US-6280563-\$ or US-6231776-\$).did.) and (Pt platinum) (((US-5079334-\$ or US-5114770-\$ or US-5125358-\$ or US-5130294-\$ or US-5132282-\$ or US-5137991-\$ or US-5147968-\$ or US-5185506-\$ or US-3638061-\$ or US-4883686-\$ or US-4842708-\$ or US-4609428-\$ or US-6117279-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6158384-\$ or US-6173673-\$ or US-6178920-\$ or US-6189482-\$ or US-6190513-\$ or US-6197166-\$ or US-6200911-\$ or US-6207901-\$ or US-5192849-\$ or US-5254821-\$).did. or (US-5256846-\$ or US-5294694-\$ or US-5296036-\$ or US-5368685-\$ or US-5439533-\$ or US-5463014-\$ or US-5470768-\$ or US-5482611-\$ or US-5487875-\$ or US-5514217-\$ or US-5527391-\$ or US-5538699-\$ or US-5563182-\$ or US-5567243-\$ or US-5639341-\$ or US-5653812-\$ or US-5665640-\$ or US-5707487-\$ or US-5716870-\$ or US-5772832-\$ or US-5866213-\$ or US-5879973-\$ or US-5968379-\$ or US-5983906-\$ or US-5994678-\$ or US-6036878-\$ or US-6051114-\$).did. or (US-6051286-\$ or US-6071372-\$ or US-6090303-\$ or US-5061838-\$ or US-5023056-\$ or US-4985114-\$ or US-4937094-\$).did.) and (Pt platinum) not (((US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$ or US-6280563-\$ or US-6231776-\$).did.) and (Pt platinum)))) and (window wall surface dielectric) and (deposit depositing deposition) and (pt platinum)</p>	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/03 18:09
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-	273	<p>(((((etch\$3 deposit depositing deposition) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$3 temperature near (window wall surface dielectric))) and (etch\$3 deposit depositing deposition) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric))) ) and (Pt platinum) not (((US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$ or US-6280563-\$ or US-6231776-\$).did.) and (Pt platinum) (((US-5079334-\$ or US-5114770-\$ or US-5125358-\$ or US-5130294-\$ or US-5132282-\$ or US-5137991-\$ or US-5147968-\$ or US-5185506-\$ or US-3638061-\$ or US-4883686-\$ or US-4842708-\$ or US-4609428-\$ or US-6117279-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6158384-\$ or US-6173673-\$ or US-6178920-\$ or US-6189482-\$ or US-6190513-\$ or US-6197166-\$ or US-6200911-\$ or US-6207901-\$ or US-5192849-\$ or US-5254821-\$).did. or (US-5256846-\$ or US-5294694-\$ or US-5296036-\$ or US-5368685-\$ or US-5439533-\$ or US-5463014-\$ or US-5470768-\$ or US-5482611-\$ or US-5487875-\$ or US-5514217-\$ or US-5527391-\$ or US-5538699-\$ or US-5563182-\$ or US-5567243-\$ or US-5639341-\$ or US-5653812-\$ or US-5665640-\$ or US-5707487-\$ or US-5716870-\$ or US-5772832-\$ or US-5866213-\$ or US-5879973-\$ or US-5968379-\$ or US-5983906-\$ or US-5994678-\$ or US-6036878-\$ or US-6051114-\$).did. or (US-6051286-\$ or US-6071372-\$ or US-6090303-\$ or US-5061838-\$ or US-5023056-\$ or US-4985114-\$ or US-4937094-\$).did.) and (Pt platinum) not (((US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$ or US-6280563-\$ or US-6231776-\$).did.) and (Pt platinum)))) and (window wall surface dielectric) same (deposit depositing deposition) same (pt platinum)</p>	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/03 18:10
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-	103	<p>((((etch\$3 deposit depositing deposition) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$3 temperature near (window wall surface dielectric))) and (etch\$3 deposit depositing deposition) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric))) and (Pt platinum) not (((US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$ or US-6280563-\$ or US-6231776-\$).did.) and (Pt platinum) (((US-5079334-\$ or US-5114770-\$ or US-5125358-\$ or US-5130294-\$ or US-5132282-\$ or US-5137991-\$ or US-5147968-\$ or US-5185506-\$ or US-3638061-\$ or US-4883686-\$ or US-4842708-\$ or US-4609428-\$ or US-6117279-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6158384-\$ or US-6173673-\$ or US-6178920-\$ or US-6189482-\$ or US-6190513-\$ or US-6197166-\$ or US-6200911-\$ or US-6207901-\$ or US-5192849-\$ or US-5254821-\$).did. or (US-5256846-\$ or US-5294694-\$ or US-5296036-\$ or US-5368685-\$ or US-5439533-\$ or US-5463014-\$ or US-5470768-\$ or US-5482611-\$ or US-5487875-\$ or US-5514217-\$ or US-5527391-\$ or US-5538699-\$ or US-5563182-\$ or US-5567243-\$ or US-5639341-\$ or US-5653812-\$ or US-5665640-\$ or US-5707487-\$ or US-5716870-\$ or US-5772832-\$ or US-5866213-\$ or US-5879973-\$ or US-5968379-\$ or US-5983906-\$ or US-5994678-\$ or US-6036878-\$ or US-6051114-\$).did. or (US-6051286-\$ or US-6071372-\$ or US-6090303-\$ or US-5061838-\$ or US-5023056-\$ or US-4985114-\$ or US-4937094-\$).did.) and (Pt platinum) not (((US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$ or US-6280563-\$ or US-6231776-\$).did.) and (Pt platinum)))) and (window wall surface dielectric) with (deposit depositing deposition) with (pt platinum)</p>	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/03 18:10
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-	8	<p>(((etch\$3 deposit depositing deposition) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$3 temperature near (window wall surface dielectric))) and (etch\$3 deposit depositing deposition) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric))) and (Pt platinum) not (((US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$ or US-6280563-\$ or US-6231776-\$).did.) and (Pt platinum)) ((US-5079334-\$ or US-5114770-\$ or US-5125358-\$ or US-5130294-\$ or US-5132282-\$ or US-5137991-\$ or US-5147968-\$ or US-5185506-\$ or US-3638061-\$ or US-4883686-\$ or US-4842708-\$ or US-4609428-\$ or US-6117279-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6158384-\$ or US-6173673-\$ or US-6178920-\$ or US-6189482-\$ or US-6190513-\$ or US-6197166-\$ or US-6200911-\$ or US-6207901-\$ or US-5192849-\$ or US-5254821-\$).did. or (US-5256846-\$ or US-5294694-\$ or US-5296036-\$ or US-5368685-\$ or US-5439533-\$ or US-5463014-\$ or US-5470768-\$ or US-5482611-\$ or US-5487875-\$ or US-5514217-\$ or US-5527391-\$ or US-5538699-\$ or US-5563182-\$ or US-5567243-\$ or US-5639341-\$ or US-5653812-\$ or US-5665640-\$ or US-5707487-\$ or US-5716870-\$ or US-5772832-\$ or US-5866213-\$ or US-5879973-\$ or US-5968379-\$ or US-5983906-\$ or US-5994678-\$ or US-6036878-\$ or US-6051114-\$).did. or (US-6051286-\$ or US-6071372-\$ or US-6090303-\$ or US-5061838-\$ or US-5023056-\$ or US-4985114-\$ or US-4937094-\$).did.) and (Pt platinum) not (((US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$ or US-6280563-\$ or US-6231776-\$).did.) and (Pt platinum)))) and (window wall surface dielectric) near2 (deposit depositing deposition) near2 (pt platinum)</p>	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/03 18:10
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-	30	(microwave inducti\$4) near3 plasma and (((etch\$3 deposit depositing deposition) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$3 temperature near (window wall surface dielectric))) and (etch\$3 deposit depositing deposition) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric)) ) and (Pt platinum) not (((US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$ or US-6280563-\$ or US-6231776-\$).did.) and (Pt platinum)) (((US-5079334-\$ or US-5114770-\$ or US-5125358-\$ or US-5130294-\$ or US-5132282-\$ or US-5137991-\$ or US-5147968-\$ or US-5185506-\$ or US-3638061-\$ or US-4883686-\$ or US-4842708-\$ or US-4609428-\$ or US-6117279-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6158384-\$ or US-6173673-\$ or US-6178920-\$ or US-6189482-\$ or US-6190513-\$ or US-6197166-\$ or US-6200911-\$ or US-6207901-\$ or US-5192849-\$ or US-5254821-\$).did. or (US-5256846-\$ or US-5294694-\$ or US-5296036-\$ or US-5368685-\$ or US-5439533-\$ or US-5463014-\$ or US-5470768-\$ or US-5482611-\$ or US-5487875-\$ or US-5514217-\$ or US-5527391-\$ or US-5538699-\$ or US-5563182-\$ or US-5567243-\$ or US-5639341-\$ or US-5653812-\$ or US-5665640-\$ or US-5707487-\$ or US-5716870-\$ or US-5772832-\$ or US-5866213-\$ or US-5879973-\$ or US-5968379-\$ or US-5983906-\$ or US-5994678-\$ or US-6036878-\$ or US-6051114-\$).did. or (US-6051286-\$ or US-6071372-\$ or US-6090303-\$ or US-5061838-\$ or US-5023056-\$ or US-4985114-\$ or US-4937094-\$).did.) and (Pt platinum) not (((US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$ or US-6280563-\$ or US-6231776-\$).did.) and (Pt platinum)))) and (window wall surface dielectric) with (deposit depositing deposition) with (pt platinum))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/03 18:18
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-	17	(microwave inducti\$4) near plasma and ((((etch\$3 deposit depositing deposition) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$3 temperature near (window wall surface dielectric))) and (etch\$3 deposit depositing deposition) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric)) ) and (Pt platinum) not (((US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$ or US-6280563-\$ or US-6231776-\$).did.) and (Pt platinum)) (((US-5079334-\$ or US-5114770-\$ or US-5125358-\$ or US-5130294-\$ or US-5132282-\$ or US-5137991-\$ or US-5147968-\$ or US-5185506-\$ or US-3638061-\$ or US-4883686-\$ or US-4842708-\$ or US-4609428-\$ or US-6117279-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6158384-\$ or US-6173673-\$ or US-6178920-\$ or US-6189482-\$ or US-6190513-\$ or US-6197166-\$ or US-6200911-\$ or US-6207901-\$ or US-5192849-\$ or US-5254821-\$).did. or (US-5256846-\$ or US-5294694-\$ or US-5296036-\$ or US-5368685-\$ or US-5439533-\$ or US-5463014-\$ or US-5470768-\$ or US-5482611-\$ or US-5487875-\$ or US-5514217-\$ or US-5527391-\$ or US-5538699-\$ or US-5563182-\$ or US-5567243-\$ or US-5639341-\$ or US-5653812-\$ or US-5665640-\$ or US-5707487-\$ or US-5716870-\$ or US-5772832-\$ or US-5866213-\$ or US-5879973-\$ or US-5968379-\$ or US-5983906-\$ or US-5994678-\$ or US-6036878-\$ or US-6051114-\$).did. or (US-6051286-\$ or US-6071372-\$ or US-6090303-\$ or US-5061838-\$ or US-5023056-\$ or US-4985114-\$ or US-4937094-\$).did.) and (Pt platinum) not (((US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$ or US-6280563-\$ or US-6231776-\$).did.) and (Pt platinum)))) and (window wall surface dielectric) with (deposit depositing deposition) with (pt platinum))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/03 18:28
-	0	20010050267.URPN.	USPAT	2004/05/03 18:20
-	0	20030159782.URPN.	USPAT	2004/05/03 18:27

-	23	(microwave inducti\$4) near plasma and ((((etch\$3 deposit depositing deposition) near (metal\$3 pt cu al ti ru ir conduct\$3) and (RF microwave inducti\$4) and (heat\$3 temperature near (window wall surface dielectric))) and (etch\$3 deposit depositing deposition) near ((metal\$3 pt cu al ti ru ir conduct\$3) and (window wall surface dielectric)) ) and (Pt platinum) not (((US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$ or US-6280563-\$ or US-6231776-\$).did.) and (Pt platinum)) ((US-5079334-\$ or US-5114770-\$ or US-5125358-\$ or US-5130294-\$ or US-5132282-\$ or US-5137991-\$ or US-5147968-\$ or US-5185506-\$ or US-3638061-\$ or US-4883686-\$ or US-4842708-\$ or US-4609428-\$ or US-6117279-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6158384-\$ or US-6173673-\$ or US-6178920-\$ or US-6189482-\$ or US-6190513-\$ or US-6197166-\$ or US-6200911-\$ or US-6207901-\$ or US-5192849-\$ or US-5254821-\$).did. or (US-5256846-\$ or US-5294694-\$ or US-5296036-\$ or US-5368685-\$ or US-5439533-\$ or US-5463014-\$ or US-5470768-\$ or US-5482611-\$ or US-5487875-\$ or US-5514217-\$ or US-5527391-\$ or US-5538699-\$ or US-5563182-\$ or US-5567243-\$ or US-5639341-\$ or US-5653812-\$ or US-5665640-\$ or US-5707487-\$ or US-5716870-\$ or US-5772832-\$ or US-5866213-\$ or US-5879973-\$ or US-5968379-\$ or US-5983906-\$ or US-5994678-\$ or US-6036878-\$ or US-6051114-\$).did. or (US-6051286-\$ or US-6071372-\$ or US-6090303-\$ or US-5061838-\$ or US-5023056-\$ or US-4985114-\$ or US-4937094-\$).did.) and (Pt platinum) not (((US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$ or US-6280563-\$ or US-6231776-\$).did.) and (Pt platinum)))) and (window wall surface dielectric) same (deposit depositing deposition) same (pt platinum)) not (((US-6036878-\$ or US-6051286-\$ or US-6051114-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$ or US-6280563-\$ or US-6231776-\$).did.) and (Pt platinum)) ((US-5079334-\$ or US-5114770-\$ or US-5125358-\$ or US-5130294-\$ or US-5132282-\$ or US-5137991-\$ or US-5147968-\$ or US-5185506-\$ or US-3638061-\$ or US-4883686-\$ or US-4842708-\$ or US-4609428-\$ or US-6117279-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6158384-\$ or US-6173673-\$ or US-6178920-\$ or US-6189482-\$ or US-6190513-\$ or US-6197166-\$ or US-6200911-\$ or US-6207901-\$ or US-5192849-\$ or US-5254821-\$).did. or (US-5256846-\$ or US-5294694-\$ or US-5296036-\$ or US-5368685-\$ or US-5439533-\$ or US-5463014-\$ or US-5470768-\$ or US-5482611-\$ or US-5487875-\$ or US-5514217-\$ or US-5527391-\$ or US-5538699-\$ or US-5563182-\$ or US-5567243-\$ or US-5639341-\$ or US-5653812-\$ or US-5665640-\$ or US-5707487-\$ or US-5716870-\$ or US-5772832-\$ or US-5866213-\$ or US-5879973-\$ or US-5968379-\$ or US-5983906-\$ or US-5994678-\$ or US-6036878-\$ or US-6051114-\$).did. or (US-6051286-\$ or US-6071372-\$ or US-6090303-\$ or US-5061838-\$ or US-5023056-\$ or US-4985114-\$ or US-4937094-\$).did.) and	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/03 18:29
Search History	5/4/04 1:15 PM Page 14 C:\APPS\EAST\Workspaces\09 series\109896786 CPA of 09124291-001	US-6036878-\$ or US-6051286-\$ or US-6071372-\$ or US-6124834-\$ or US-6136685-\$ or US-6139923-\$ or US-6189482-\$ or US-6190513-\$ or US-6280563-\$ or US-6231776-\$).did.) and		

-	14	etch\$3 near (Pt platinum) with (microwave inductively iductive induction)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/04 12:22
-	35	etch\$3 with (Pt platinum) with (microwave inductively iductive induction) not (etch\$3 near (Pt platinum) with (microwave inductively iductive induction))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/04 12:23
-	17	etch\$3 near3 (Pt platinum) with (microwave inductively iductive induction) not (etch\$3 near (Pt platinum) with (microwave inductively iductive induction))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/04 12:23
-	14	etch\$3 near2 (Pt platinum) with (microwave inductively iductive induction) not (etch\$3 near (Pt platinum) with (microwave inductively iductive induction))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/04 12:56
-	3	(etch\$3 near3 (Pt platinum) with (microwave inductively iductive induction) not (etch\$3 near (Pt platinum) with (microwave inductively iductive induction))) not (etch\$3 near2 (Pt platinum) with (microwave inductively iductive induction) not (etch\$3 near (Pt platinum) with (microwave inductively iductive induction)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/04 13:00
-	18	(etch\$3 with (Pt platinum) with (microwave inductively iductive induction) not (etch\$3 near (Pt platinum) with (microwave inductively iductive induction))) not (etch\$3 near3 (Pt platinum) with (microwave inductively iductive induction) not (etch\$3 near (Pt platinum) with (microwave inductively iductive induction)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/05/04 13:01